



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Shiga et al.

Serial No.: 10/726,590

Filed: 12/4/2003

Title: SEMICONDUCTOR DEVICE AND  
METHOD OF MANUFACTURING SAME

Atty. Dkt.: 01-522

Art Unit: 2818

Examiner: TRAN

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Window, Mail Stop Amendment  
Randolph Building  
401 Dulany St.  
Alexandria, VA 22314

Date: 30 June 2005

**AMENDMENT UNDER 37 CFR 1.111**

Sir:

In response to the office action mailed 10 January 2005, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.